



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: OHTOMO et al

EXPEDITED PROCEDURE

September 12, 2005

Serial No.:

09/943,507

Filed:

August 31, 2001

For:

Thin Film Head, Producing Method Thereof

And Magnetic Disk Apparatus

Art Unit:

2652

Examiner:

T. Chen

AMENDMENT AFTER FINAL REJECTION

Mail Stop: AF Amendment (Fee)

Commissioner For Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application, in response to the Office Action dated May 12, 2005. The amendments are listed below and set forth on the following pages.

Amendments to the Claims; and

Remarks are included following the amendments.